

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI et al.**

Art Unit: **1792**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**
Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 22, 2009

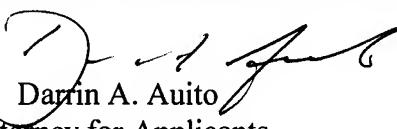
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 20, 2009 for one month from November 20, 2009 to December 22, 2009 (December 20, 2009 falling on a Sunday, and the USPTO was closed on December 21, 2009 due to inclement weather).

Attached please find payment in the amount of \$130.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP


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